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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: TANABE et al.

Patent No.: 6,861,614 091612, SS

Filed: March 1, 2005

For: System for the Formation of a Silicon Thin Film...

Group: 1725

Confirmation No.: 9380 DOCKET: NEC WNZ-2212

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

STATUS REQUEST

Dear Sir:

Applicants have filed a Petition for Certificate of Correctness in the above referenced Patent. Applicants have yet to receive an Action on the Petition. Please advise of the status of this Petition. Thank you in advance for your cooperation in this matter.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,



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Patent No. 6,861,614
Docket No. NEC WNZ-2212
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CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 15 2006 at Tucson, Arizona.

By: Patricia Sorenson

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